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PATENT

IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

Applicant(s): Takanori SAITO, et al.

U.S. Serial No.: 10/551,033

Group Art Unit: 3749

Filed: September 27, 2005

Examiner: Gregory A. Wilson

For: THERMAL PROCESSING METHOD AND THERMAL PROCESSING UNIT

SIXTH INFORMATION DISCLOSURE STATEMENT

Commissioner for Patents
P.O. Box 1450
Alexandria, VA 22313-1450

Sir:

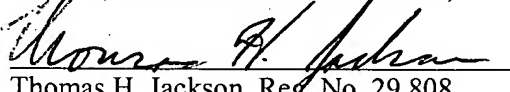
Pursuant to the duty of disclosure under 37 C.F.R. 1.56, Applicants are enclosing an Information Disclosure Citation Form (PTO-1449) which lists the references cited in the Supplementary European Search Report issued on April 11, 2008, for counterpart Appln. No. EP 04 72 4135.

Applicants certify under 37 C.F.R. 1.97(e)(1) that each item of information contained in this Information Disclosure Statement was first cited in communication from a foreign patent office in a counterpart foreign application not more than three months prior to the filing of the information disclosure statement.

It is respectfully requested that the cited documents be considered by the Examiner, that they be made officially of record therein, and that the documents be listed on the face of any patent which may issue from this application. An Office Action on the merits has issued for this application. In accordance with the requirements of 37 C.F.R. §1.97(c), Applicants also attach a check which includes payment of the \$180 requisite fee (37 C.F.R §1.17(p)).

Respectfully submitted,
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